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	Filing Date		2007-07-06
	First Named Inventor	Jin-Woo CHEON	
	Art Unit	1793	
	Examiner Name	Anthony J. ZIMMER	
	Attorney Docket Number	54577-10900	

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	1	KURIHARA, L.K. et al. "Nanocrystalline Metallic Powders and Films Produces by the Polyol Method" NanoStructured Materials, Vol. 5, No. 6, pp. 607-613, 1995, Elsevier Science Ltd., USA	<input type="checkbox"/>
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